

Docket No.: 1592-0172PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tadashi TERASAKI et al.

Application No.: 10/594,739

Confirmation No.: 5299

Filed: August 22, 2007

Art Unit: 2818

For: PRODUCING METHOD OF
SEMICONDUCTOR DEVICE

Examiner: J. Han

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 3, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims

Remarks/Arguments